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Docket No.: 2336-183

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): HONG, Yoon Shik et al.

Confirmation No. 3649

U.S. Patent Application No. 10/606,348

Group Art Unit: 2874

Filed: June 26, 2003

Examiner:

For

MICROELECTROMECHANICAL SYSTEMS (MEMS) VARIABLE OPTICAL

ATTENUATOR

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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Date: February 7, 2005

		DISCLOSURE	ATTY. DOCKET NO. 2336-183		U.S. PATENT APPLICATION NO. 10/606,348			
OIPE	CITATION APPLICA	APPLICANT HONG, Yoon Shik et al. et al.						
MADEMARIS	(PTO-1449)			FILING DATE June 26, 2003		GROUP 2874		
PADEMARK		U.S. PATENT	DOCUMENTS					
EXAMINER'S INITIALS	PATENT NO. DATE		NAME	CLASS	SUBCLASS	FILING DATE		
	6,222,656	4/2001	Eu					
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L		FOREIGN PATE	NT DOCUMENTS		<u> </u>			
EXAMINER'S INITIALS	PATENT NO.	PATENT NO. DATE		CLASS	SUBCLASS	Translation Yes No		
	OTHE	RART (Including Author,	Title, Date, Pertin	ent Pages, Et	c.)			
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EXAMINER	-		DATE CONSIDER	RED				

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.